Increasing Dust Removal Efficiency of Electrodynamic Screens Using Frequency Optimization via COMSOL Multiphysics®

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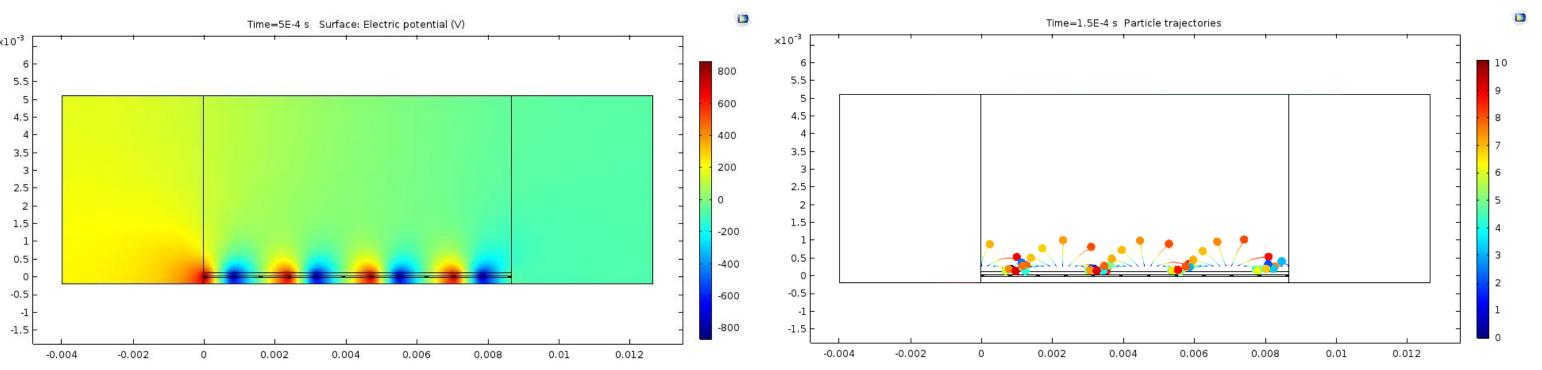
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Introduction

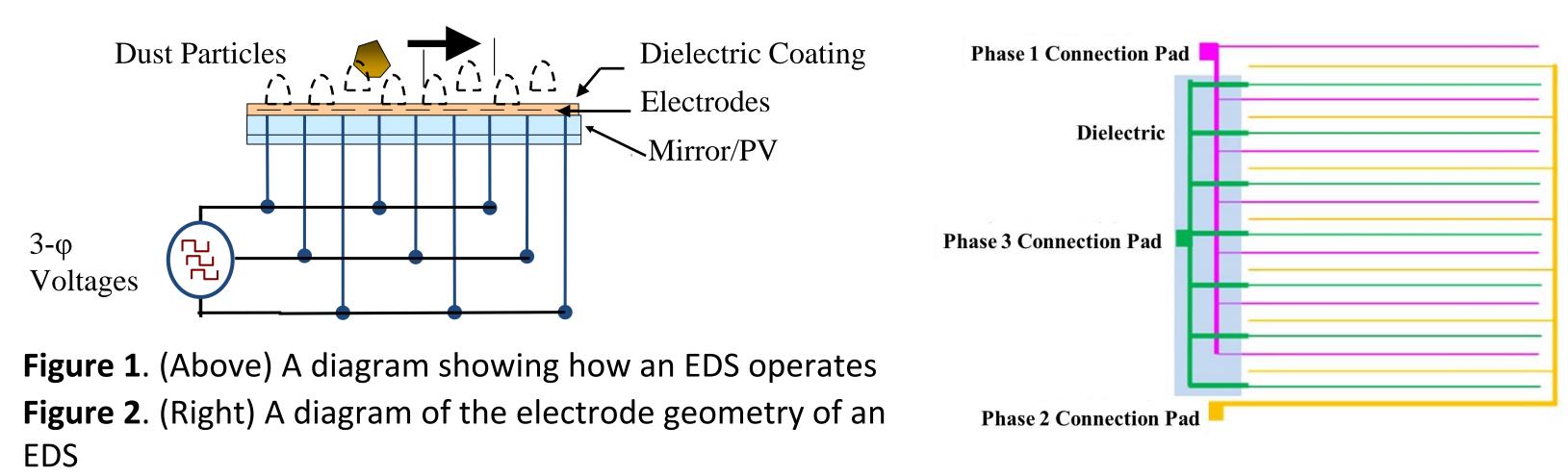
Utility-scale solar power plants are often located in deserts where they receive large amounts of sunlight but also experience regular dust storms. These storms deposit dust on the power plants' photovoltaic (PV) and concentrating solar power (CSP) surfaces, decreasing efficiency by 5 to 40% annually. [1] Current dust cleaning methods are water-, labor-, and energy-intensive, and an alternative cleaning method being developed is the electrodynamic screen (EDS). [2] [3]

Results

For each frequency $\omega = \{1, 5, 25, 50, 100, 150, 200, 250 Hz\}$, a time-dependent electrostatics study was conducted, resulting in solutions for the system's electric potential. The results of these simulations were used by the time-dependent particle tracing studies, which resulted in the trajectories of 50 particles over time t = [0s, 1s].



An EDS is a series of parallel electrodes embedded between two thin dielectric layers. A voltage wave is applied across these electrodes resulting in oscillating potentials and creating a wave pattern in the electric field above the EDS surface. This electric field charges dust particles and directs their motion off the EDS surface.



Computational Methods

A model of the EDS system's electrostatics and particle movement was created using the following COMSOL physics interfaces:

Figure 4, 5. The electric potential and particle trajectories of a 5Hz EDS system at time t=0.0005 s.

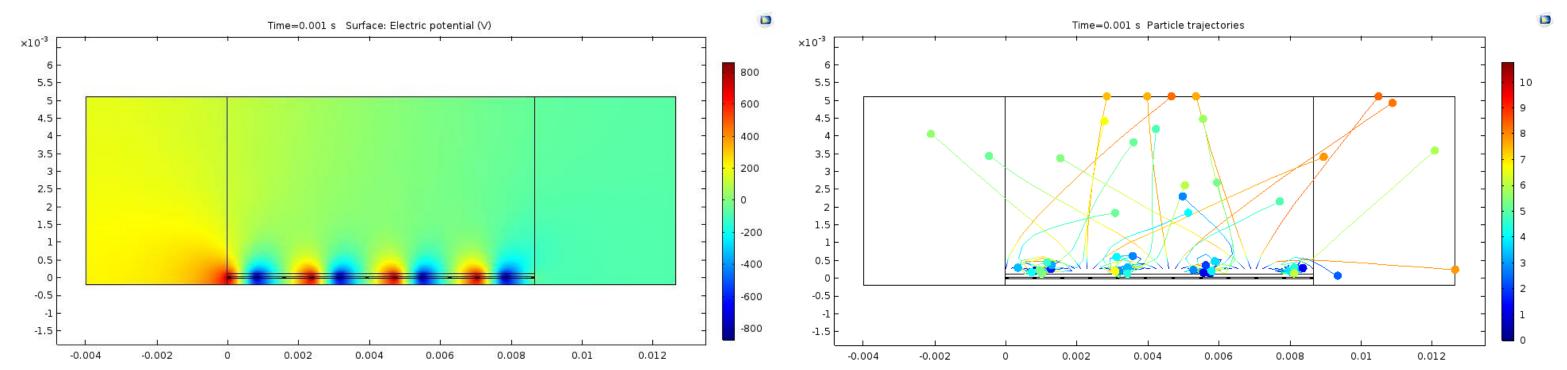
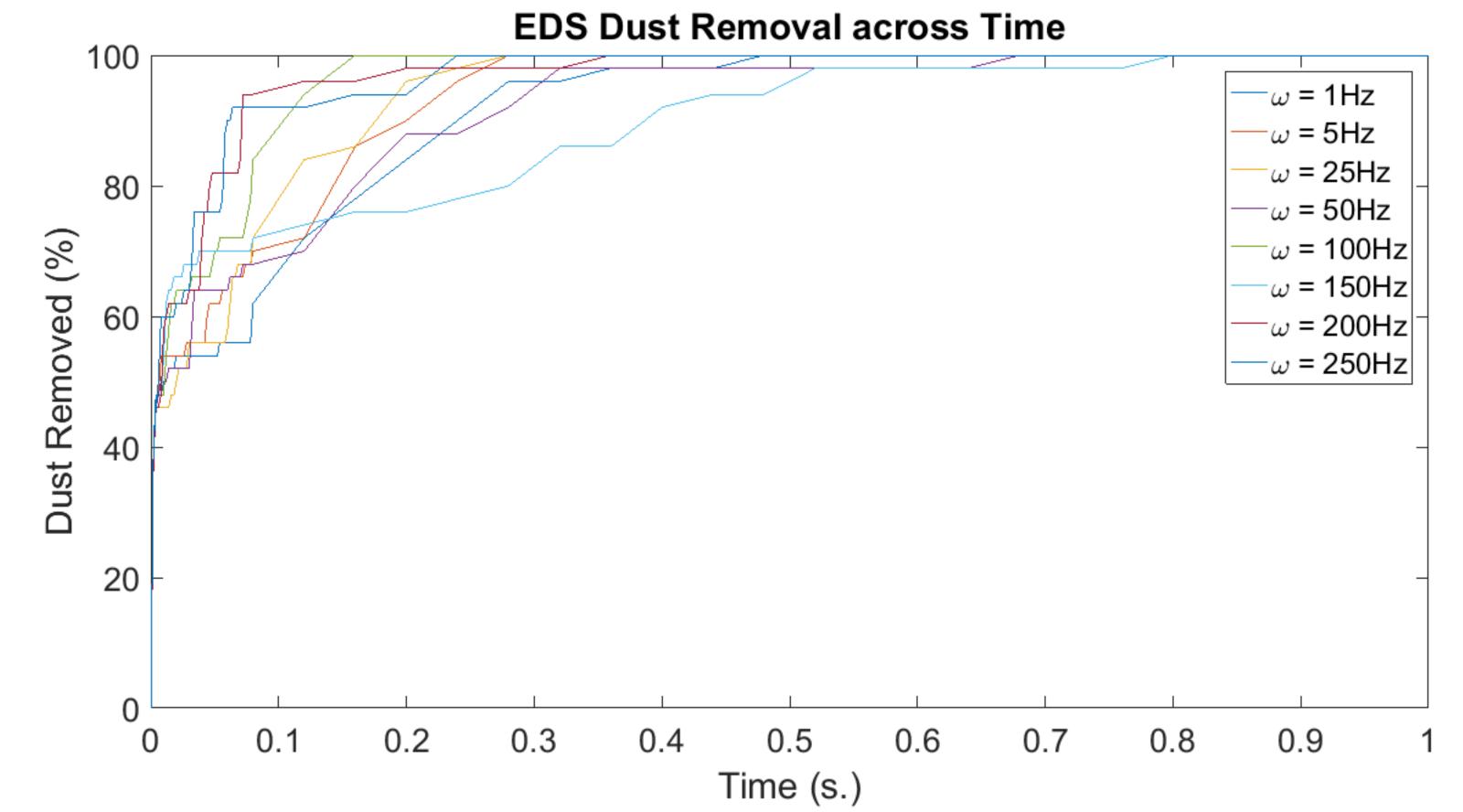


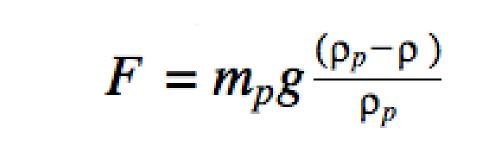
Figure 6, 7. The electric potential and particle trajectories of a 5Hz EDS system at time t=0.001 s.



AC/DC: Electrostatics Electrode Potentials $V_1 = V_{max} \cdot cos(\omega t + 30^\circ)$ $V_2 = V_{max} \cdot cos(\omega t + 150^\circ)$ $V_3 = V_{max} \cdot cos(\omega t + 270^\circ)$



Gravity



Electric Field $\nabla \cdot D = \rho_V$ $E = -\nabla V$ Electrical Force

 $F = \frac{1}{\tau_p} m(u - v)$ $\tau_p = \frac{\rho_p d_p^2}{18\mu}$

The geometry of the EDS system being modeled is shown below:

Particle Properties	Value	Units	6.5 ×10 ⁻³	0
mass, m _p	$0.33 * 10^6$	kg	5.5 5 4.5 4.5	
density, ρ_p	2200	kg/m^3	4 3.5	
diameter, d_p	60	m	³ 2.5 2	-
charge, q	$30 * 10^{-12}$	С	1.5 1 1 0.5	
charge number, Z	$1.8 * 10^8$			
		1	-1	

Figure 8. A graph of the percentage of the system's 50 particles which are removed during the first second of EDS activation. Each colored line represents a different EDS operation frequency.

Conclusions

The results demonstrate that operating an EDS at a higher relative frequency results in faster dust removal. But because all frequencies clear 100% of the dust within the first second of operation, the dust removal speed may not need to be the primary factor considered in choosing EDS operating frequency. Future work includes modeling the effects of more forces, modeling different sized and charged dust particles, and validating the results against experimental data.

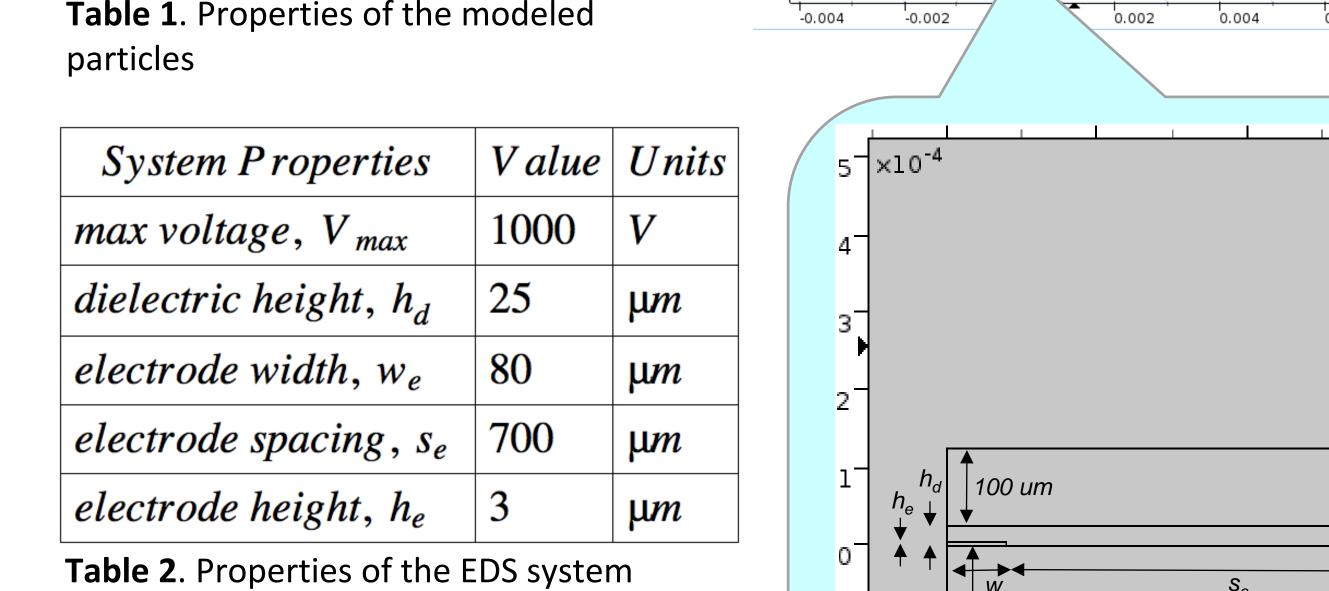
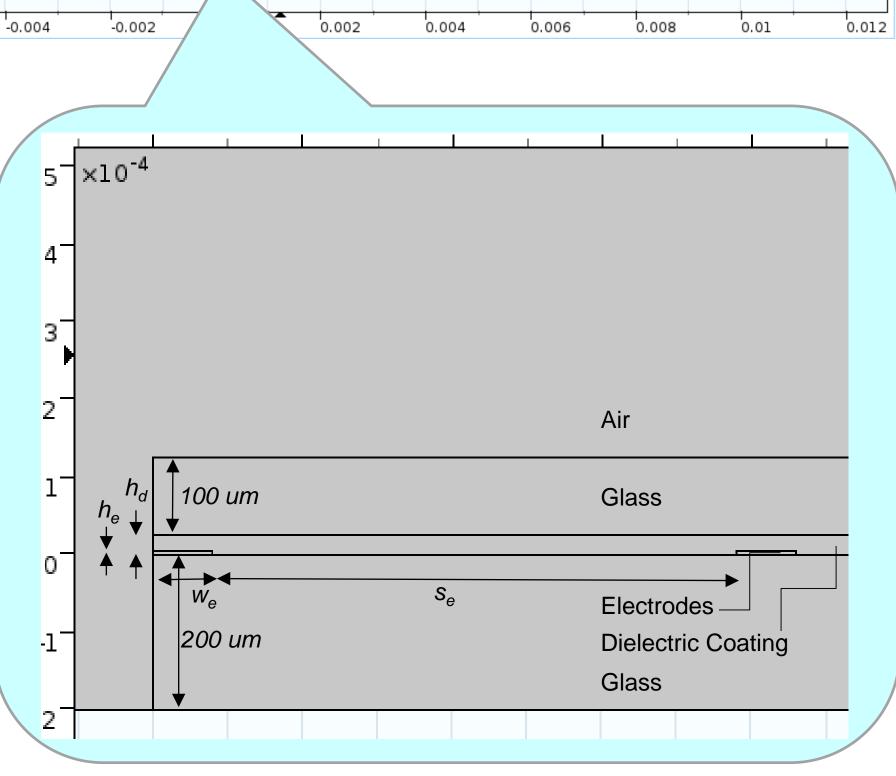


Figure 3. (Right) A diagram showing the cross-section of a 12-electrode EDS, with a magnification to show the system's layers.



References

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Acknowledgements

The work is supported by a grant from the Department of Energy (DOE CSP APOLLO EE-0007119) on "Enhancement of Optical Efficiency of CSP Mirrors for Reducing O&M Cost via Near-Continuous Operation of Self-Cleaning Electrodynamic Screens (EDS)" and cost-sharing grants from MassCEC and EDS Chile SpA, Chile. The work is performed in collaboration with Corning Research and Development Corporation, Eastman Kodak, Sandia National Lab, Industrial Technology Research Institute, Taiwan, and EDS Chile SpA, Chile.

Excerpt from the Proceedings of the 2017 COMSOL Conference in Boston